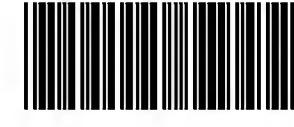


APPLICATION DATA SHEET

Electronic Version v14

Stylesheet Version v14.0

Title of Invention	PRESSURE ASSISTED WAFER HOLDING APPARATUS AND CONTROL METHOD
Application Type :	regular, utility
Attorney Docket Number :	FIS920040119US1
Correspondence address:	
Customer Number:	29371
	
Inventors Information:	
<u>Inventor 1:</u>	
Applicant Authority Type:	Inventor
Citizenship:	US
Given Name:	David
Middle Name:	J.
Family Name:	Bain
Residence:	
City of Residence:	Newburgh
State of Residence:	NY
Country of Residence:	US
Address-1 of Mailing Address:	1211 Union Ave
Address-2 of Mailing Address:	
City of Mailing Address:	Newburgh
State of Mailing Address:	NY
Postal Code of Mailing Address:	12550
Country of Mailing Address:	US
Phone:	
Fax:	
E-mail:	
<u>Inventor 2:</u>	
Applicant Authority Type:	Inventor
Citizenship:	US
Given Name:	Christopher
Middle Name:	S.

Family Name:	Birchard
Residence:	
City of Residence:	Pine Bush
State of Residence:	NY
Country of Residence:	US
Address-1 of Mailing Address:	173 Vinegar Hill Road
Address-2 of Mailing Address:	
City of Mailing Address:	Pine Bush
State of Mailing Address:	NY
Postal Code of Mailing Address:	12566
Country of Mailing Address:	US
Phone:	
Fax:	
E-mail:	

Inventor 3:

Applicant Authority Type:	Inventor
Citizenship:	US
Given Name:	Keith
Middle Name:	Kwong-Hon
Family Name:	Wong
Residence:	
City of Residence:	Wappingers Falls
State of Residence:	NY
Country of Residence:	US
Address-1 of Mailing Address:	42 Mina Drive
Address-2 of Mailing Address:	
City of Mailing Address:	Wappingers Falls
State of Mailing Address:	NY
Postal Code of Mailing Address:	12590
Country of Mailing Address:	US
Phone:	
Fax:	
E-mail:	

Assignee 1:

Organization Name:	International Business Machines Corporation
Address-1 of Mailing Address:	New Orchard Road
Address-2 of Mailing Address:	
City of Mailing Address:	Armonk
State of Mailing Address:	NY

Postal Code of Mailing Address: 10504

Country of Mailing Address: US

Phone:

Fax:

E-mail: